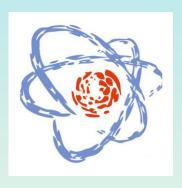


### The 25<sup>th</sup> conference of AYSS



## Development of methods for SiPM mass testing.

<u>Alexey Chetverikov</u>, Anfimov Nikolay, Fedoseev Dmitry, Olshevsky Alexander Rybnikov Arseniy, Selyunin Alexander, **DLNP, JINR** 

#### **Supported by**



Under grant #21-42-00023





### **JUNO**

### (The Jiangmen Underground Neutrino Observatory)

#### **Goals:**

- Neutrino mass hierarchy Measurements
- Oscillation parameters measurements
- Astrophysics and rare processes

#### **Location:**

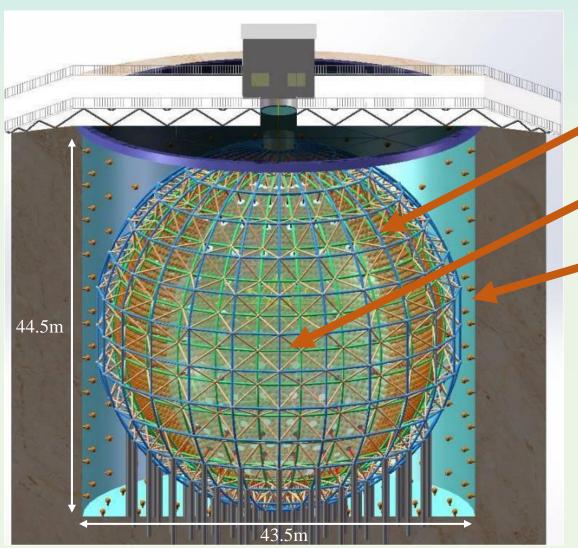


#### **Powerful source:**

Yangjiang and Taishan power plants 26.6 GWth in 2020, later 35.7 GWth

Ideal baseline:

53 km



- Acrylic Sphere 35.4m diameter

- 20 kton LAB based liquid scintillator

- Water Cherenkov Veto 20kt ultrapure water and 2000 20" PMTs

- About 20,000 large 20"photomultiplier tubes (PMTs)

- 25000 3" small PMTs

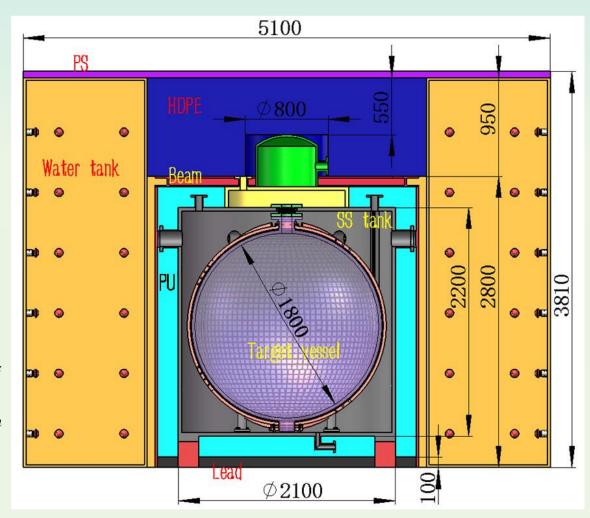
- 700 m underground

### **TAO**

#### The Taishan Antineutrino Observatory (satellite experiment)

### The main purposes of the TAO experiment are:

- 1) to provide a reference spectrum for JUNO.
- 2) to provide a benchmark measurement to test nuclear databases.
- 3)to provide increased reliability in measured isotopic antineutrino yields.
- 4) to provide an opportunity to improve nuclear physics knowledge of neutron-rich isotopes.
- 5) to search for light sterile neutrinos with a mass scale around 1 eV;
- 6) to provide increased reliability and verification of the technology for reactor monitoring and safeguard.



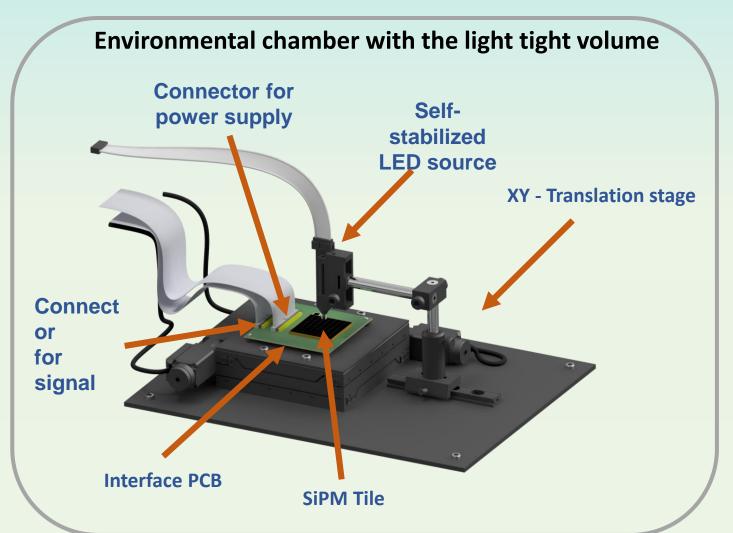
- TAO will be placed at ~ 30 m from a core of the Taishan Nuclear Power Plant.
- A spherical acrylic vessel will be contain ~ 2.8 ton gadoliniumdoped liquid scintillator.
  - TAO will be operates at -50C celsius
- Sphere will be covered by ~10 m2 Silicon Photomultipliers (SiPMs)
  - total number of tiles ~ 4000 pcs
  - all tiles need to be characterized

Schematic view of the TAO detector.

### **SiPM parameters Requirements**

Parameters	Specification	Comments
PDE	≥ 50%	at 420 nm, not including correlated noise
Dark count rate	≤ 100 Hz/mm2	at -50°C
Probability of correlated noise	≤ 10%	including cross talk and afterpulsing
Uniformity of Vbd	≤ 10%	to avoid bias voltage tuning
Size of the SiPM device	≥ 6 x 6 mm2	for easy handling
SiPM coverage within tiles	≤ 94%	not included in SiPM's PDE

### Measurement stand concept



#### **Measurement procedure:**

1	SiPM Tile installation	~5 min	
2	Hot scan	~45 min	+20°C, 5mm/s 1kHz
3	Cooling down	~30 min	~3 ºC/min
4	Cold scan	~45 min	-50ºC, 5mm/s
5	Heating	~15 min	5 ºC/min
Total time:		2h20min	

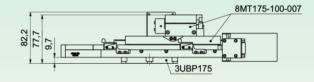
Design of the pre-measurement stand for single SiPM Tile studies

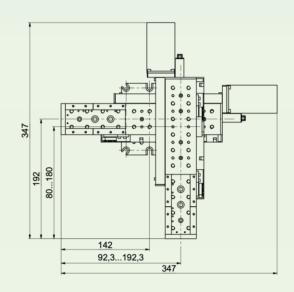
## Translation stage issue

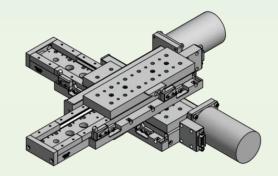
**Power supplies** 



**Motors controllers** 





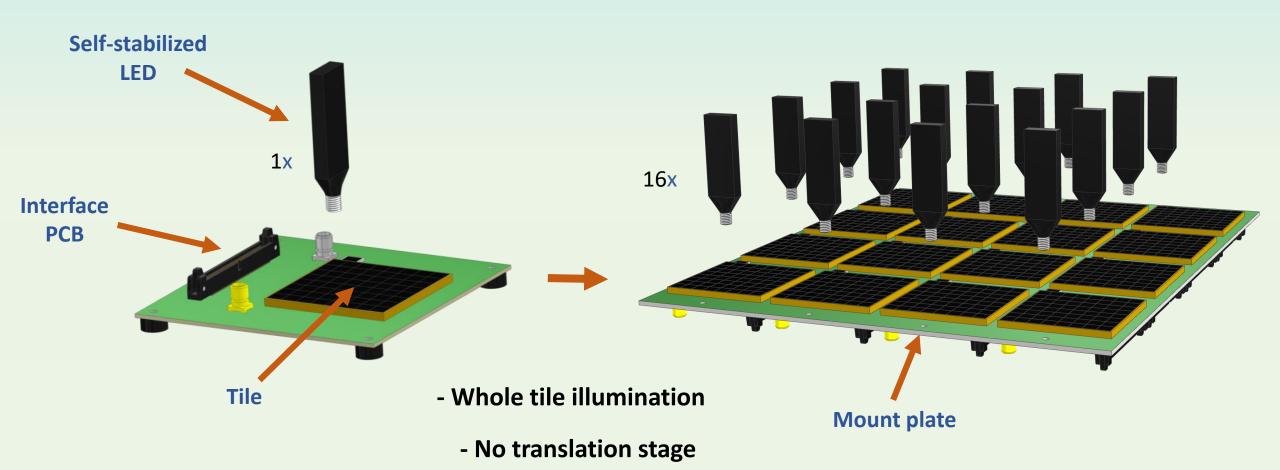


#### **Parameters:**

- Number of axes: 2 axes
- Travel range: 60-150mm (both axes)
- Speed: over 5 mm/s
- Positioning accuracy: better than 100 um
- Dimensions: less than 40x40x10 cm

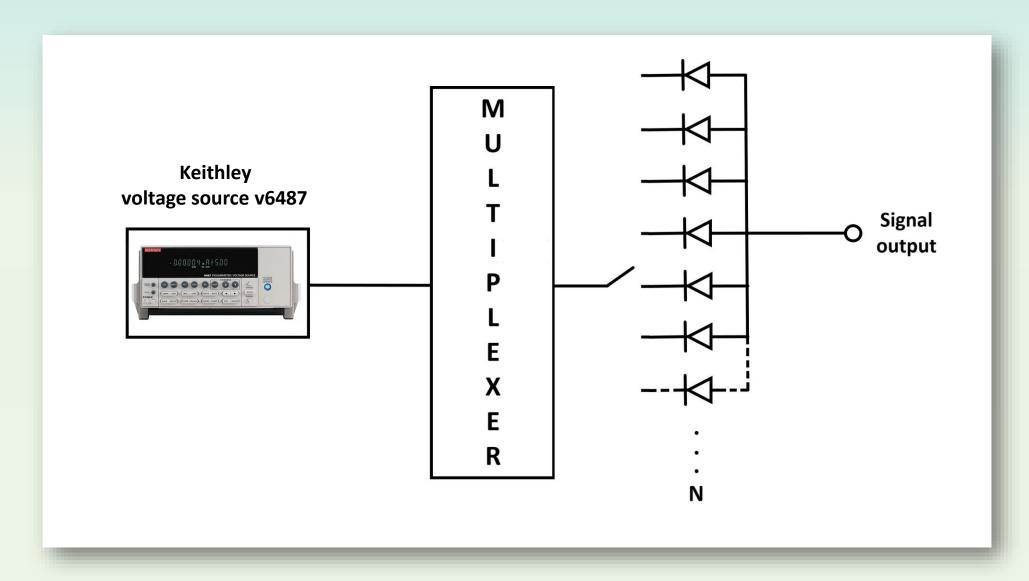
The stage doesn't operate at -50°C

### New testing approach



- Power each SiPM individually

## Multiplexer power supply concept:



### 128 channel power supply



### Power unit (128 channels)

- 4x DACs AD5535B
  - 32 channels
  - 0-200V range [adjustable by reference]
  - 550 uA/channel
  - 14 bits/selected voltage range
  - Temperature sensor
- Ix Microcontroller STM32F373 + additional multiplexers
  - 3 x24 bit ADC on chip
  - 7 channel multiplexers
  - 132 channels in total [128 voltage + 4 temperature]
- 4x integrated circuit (IC) of reference sources (selectable by jumper junction)
- current limiter IC
- 2x 68pin IDC connectors
- I HV connector for an external clean power supply
- VME 6U standard



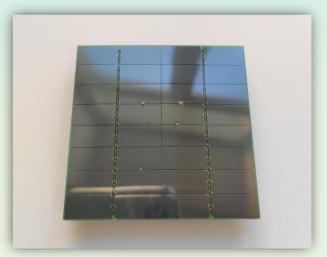


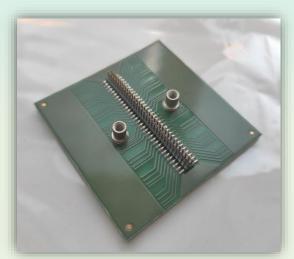


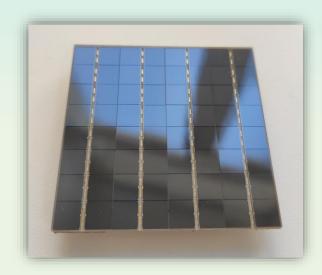


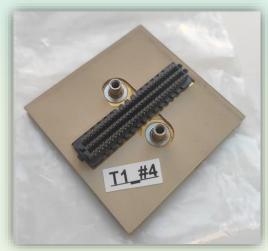
## Tiles examples

4 x 8 array 8 x 8 array







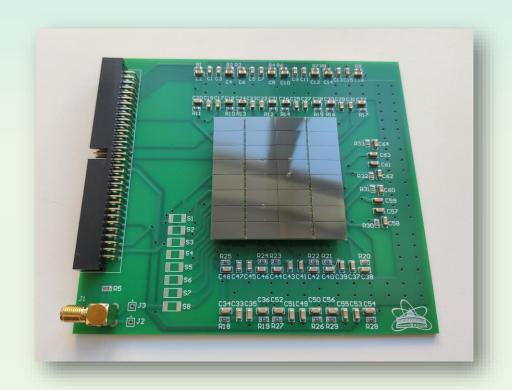


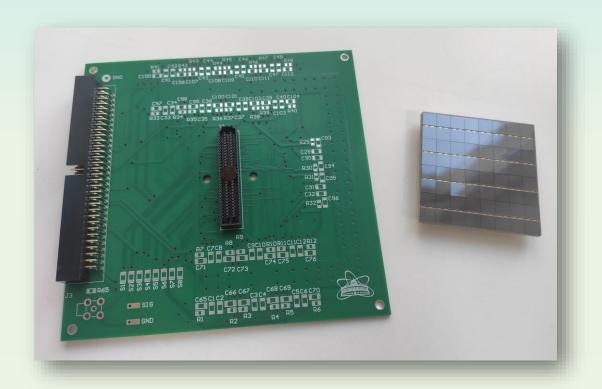
- Tiles dimensions: 50 x 50 mm

- Typical operation voltage: ~ 50V

- Dark current at Vop: ~ 3μA

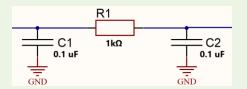
# **Interface PCBs**





**32-channel PCB for 4x8 tile prototype** 

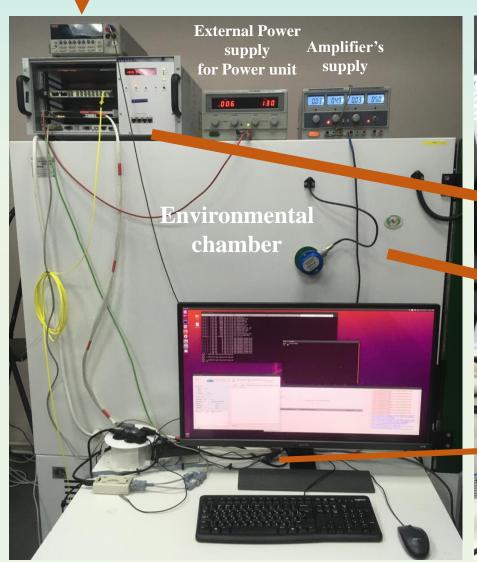
Power by pass

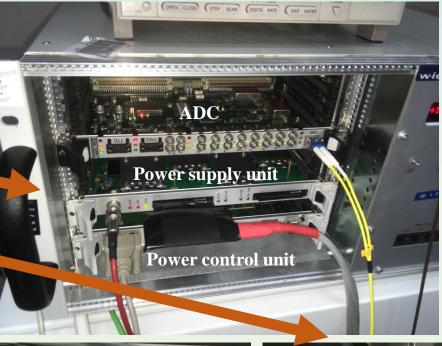


64-channel PCB for 8x8 tile prototype

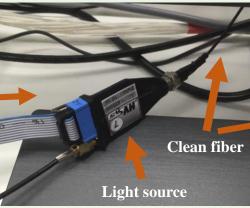
**Keithley Multimeter for temp. monitoring** 

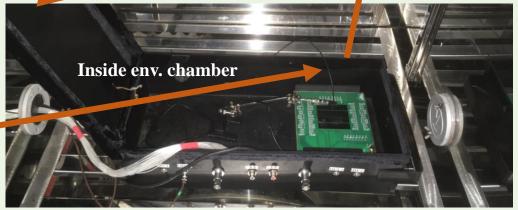
# **Equipment setup**







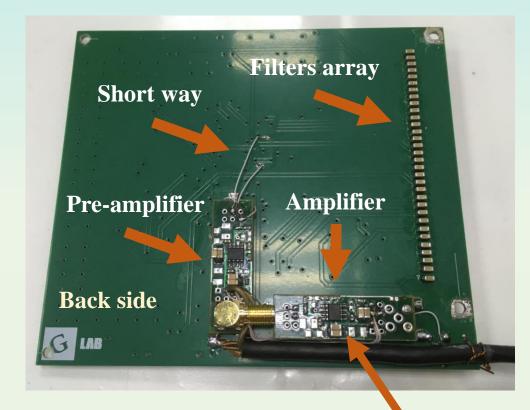




### Noise issue

First tile prototype interface PCB board

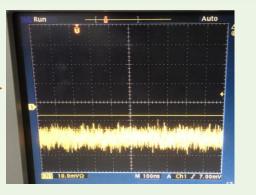


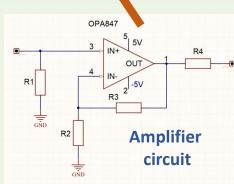


initial noise level +-150mV

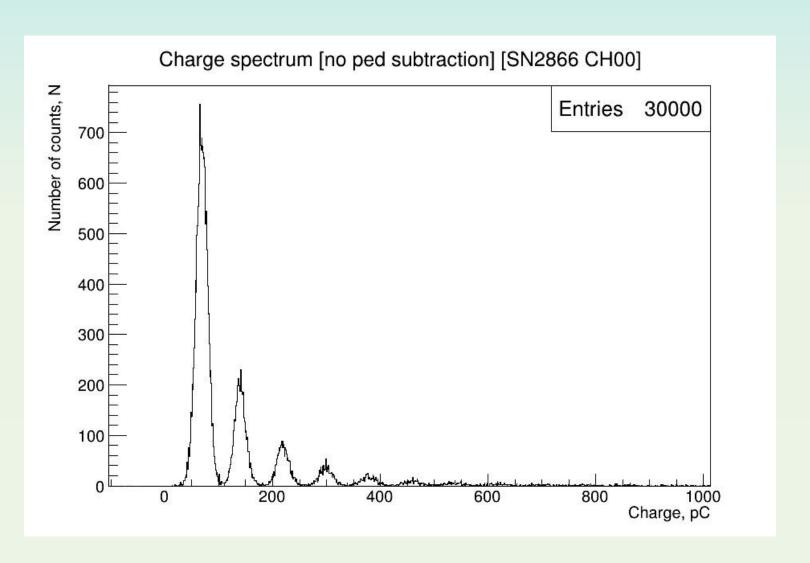
Shielding box final noise level ~ +- 5mV

charge per photoelectron ~ 8mV



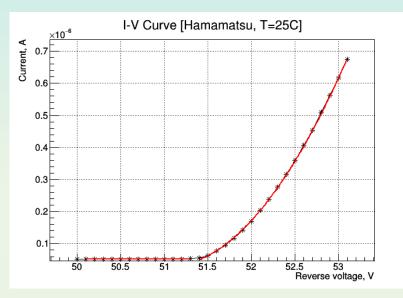


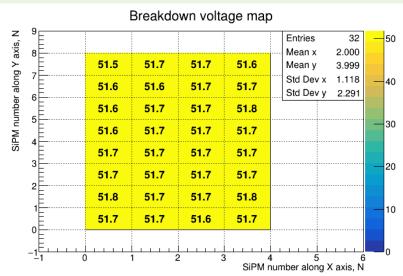
## First results

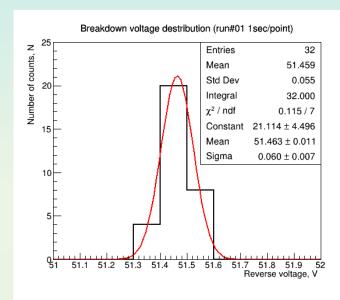


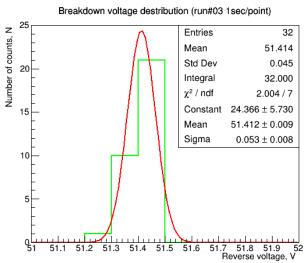
We can see the noise change spectrum!

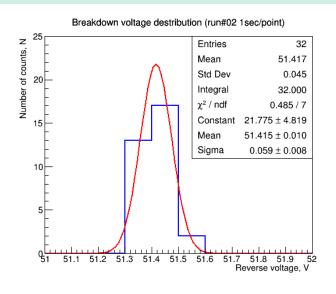
### Breakdown voltage measurements

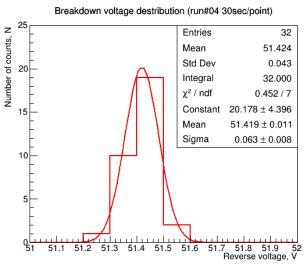












# Summary

- The measurement setup is developed and assembled
  - The testing procedure is developed and checked
    - The first tile prototype is tested



- Different prototypes testing
  - Mass testing scaling

# Thank you for attention!

# Questions?